



PATENT
0020-4666P

IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicants: Fumihiko KONUSHI et al. Conf.: 1396
Appln. No.: 09/492,803 Art Unit: 2828
Filed: January 28, 2000 Examiner: Q. P. LEUNG
For: SEMICONDUCTOR LASER DEVICE AND METHOD OF
MANUFACTURING SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 29, 2003
(Monday after Holiday)

Sir:

In response to the Office Action dated August 26, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

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